CLAIMS

- 1. A method of producing microstructure which comprises a step of making pores in a substrate to become a mold by irradiation with a focused energy beam and a step of growing a microstructure in the thus made pores.
- 2. The method of producing microstructure as defined in Claim 1, wherein said energy beam is an ion beam, electron beam, or laser beam.
- 3. The method of producing microstructure as defined in Claim 2, wherein said energy beam is one which is containing metal ions, such as Ga^{+} , Si^{+} , Si^{++} , Be^{+} , Be^{++} , Au^{+} , and Au^{++} or gaseous ions, such as H^{+} and He^{+} .
- 4. The method of producing microstructure as defined in Claim 1, wherein said pores have a diameter no larger than $100\ \mathrm{nm}$.
- 5. The method of producing microstructure as defined in Claim 2, wherein said ion beam is irradiated in such a way that the position of irradiation is within an error of ±5 nm.
- 6. The method of producing microstructure as defined in Claim 5, wherein said pores are made at intervals of 100 nm and in any array pattern.
- 7. The method of producing microstructure as defined in Claim 1, wherein said microstructure is grown

in a gas phase, liquid phase, or solid phase.

- 8. The method of producing microstructure as defined in Claim 1, wherein said microstructure is grown from a catalyst substance which has been attached to the bottom of the previously made pores.
- 9. The method of producing microstructure as defined in Claim 8, wherein said catalyst substance is precipitated at the bottom of the pores by irradiating the previously made pores with a focused energy beam in an atmosphere of a gas as a raw material of the catalyst.
- 10. The method of producing microstructure as defined in Claim 9, wherein the gas as a raw material of the catalyst is a metal gas of iron, nickel, cobalt, tungsten, molybdenum, gold, or the like.
- 11. The method of producing microstructure as defined in Claim 10, wherein the metal gas is any of $Fe(CO)_5$, $Ni(CO)_4$, WF_6 , $W(CO)_6$, $Mo(CO)_6$, $Au(CH_3)_2$, and $Al(CH_3)_2$.
- 12. The method of producing microstructure as defined in Claim 8, wherein said catalyst substance is electrochemically precipitated at the bottom of the previously made pores.
- 13. The method of producing microstructure as defined in Claim 1, wherein said microstructure is one

which is grown one-dimensionally.

- 14. The method of producing microstructure as defined in Claim 13, wherein said one-dimensional microstructure is carbon nanotube or metal nanowire.
- 15. The method of producing microstructure as defined in Claim 1, wherein said microstructure is obtained in such a form as to fill the pore.
- 16. The method of producing microstructure as defined in Claim 1, wherein said microstructure is obtained in such a form as to fill the pore and then it is removed from the pore.
- 17. A method of producing a mold which comprises a step of making pores by irradiating a substrate to become a mold with a focused energy beam.
- 18. The method of producing a mold as defined in Claim 17, wherein said energy beam is an ion beam, electron beam, or laser beam.
- 19. The method of producing a mold as defined in Claim 18, wherein said energy beam is one which is formed from metal ions, such as Ga^{+} , Si^{++} , Be^{+} , Be^{++} , Au^{+} , and Au^{++} or gaseous ions, such as H^{+} and He^{+} .
- 20. The method of producing a mold as defined in Claim 17, wherein said pores have a diameter no larger than 100 nm.

- 21. The method of producing a mold as defined in Claim 18, wherein said ion beam is irradiated in such a way that the position of irradiation is within an error of ± 5 nm.
- 22. The method of producing a mold as defined in Claim 21, wherein said pores are made at intervals of 100 nm and in any array pattern.